Application No.	Applicant(s)
10/700,770	KOMORI, SHIGEKI
Examiner	Art Unit
Igwe U. Anya	2825
GHTS. This application is subject	correspondence address pplication. If not included on will be mailed in due course. THIS to withdrawal from issue at the initiative
<u>ber 2003</u> .	
the Examiner.	
been received. been received in Application No. cuments have been received in this	s national stage application from the
tted. Note the attached EXAMINE s reason(s) why the oath or declar	R'S AMENDMENT or NOTICE OF ration is deficient.
 6. CORRECTED DRAWINGS (as "replacement sheets") must be submitted. (a) including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d). 7. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL. 	
6. ☐ Interview Summar Paper No./Mail Do 3), 7. ☐ Examiner's Amend	ate
	Examiner Igwe U. Anya ars on th cov r sh et with the COR REMAINS) CLOSED in this a cor other appropriate communication GHTS. This application is subject and MPEP 1308. Aber 2003. The Examiner. der 35 U.S.C. § 119(a)-(d) or (f). been received. been received in Application No. cuments have been received in this communication to file a replication. Attended Note the attached EXAMINE is reason(s) why the oath or declar to be submitted. The Submitted on's Patent Drawing Review (PTC) and Amendment / Comment or in the draw the header according to 37 CFR 1.121. Amendment / Comment or in the draw the header according to 37 CFR 1.121. The DEPOSIT OF BIOLOGICAL MATERIAL FOR THE PATERIAL FOR

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Allowable Subject Matter

The following is an examiner's statement of reasons for allowance. Applicant's claims 1 – 11 are allowable because prior art does not teach simultaneously forming an HDD and setting the resistance of a resistance element using one impurity implantation.

- 2. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."
- 3. Prior art made of record and not relied upon, considered pertinent to applicant's disclosure include Nanjo (USPAB 2002/0127791), and Liu et al. (US Patent 6165861).

Contact Information

4. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Igwe U. Anya whose telephone number is (571) 272-1887. The examiner can normally be reached on M - F 8:30am - 5:00pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Matthew S. Smith can be reached on (571) 272-1907. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

MATTHEW SMITH
SUPERVISORY PATENT EXAMINER
TECHNOLOGY CENTER 2800

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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June 23, 2004

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